

Contact: benoit.guilhabert@strath.ac.uk

Quotations provided for contracted services and project budgetting

Contact us if regular clean room usage is preferred.

Regular access under specific conditions and pricing (includes training)

Industries:

Services offered under Knowledge Exchange contracts. Optional access.

Contact us to discuss your requirements and receive offers.

Pricing per hour and/or per run

Process category	Equipment item	Service for Academia
Lithography and wet processing	Optical lithography	£180.00
	Laser lithography	£240.00
	Individual wetbench only*	£100.00
Inspection and metrology	Park AFM	£100.00
	Veeco optical profiler	£100.00
Dry etch	SPTS ICP1†	£180.00
	SPTS ICP2†‡	£180.00
	Oxford RIE1 ^a	£180.00
	Oxford RIE2 ^b	£180.00
	Matrix asher	£160.00
	Diener plasma asher	£100.00
Deposition	Oxford PE-CVD	£180.00
	CVC sputter**	£145+POA
	Auto500 sputter**	£145+POA
	Edwards ebeam ¹	£125+POA
	Temescal ebeam ²	£150+POA
	Parylene coater	£130.00
	Jpelec RTA	£100.00
Assembly and packaging	K&S wedge wirebonder	£120.00
	Ball bonder	£120.00
	Flipchip bonder	£100.00
Electrical testing	Wentworth probe station	£110.00
	Signatone Wavelink 210E	£150.00

*Some chemicals are charged for

†Cl₂ and BCl₃ chemistry with Ar, N₂ and O₂

‡System under maintenance (no leadtime)

^a Polymer and dielectric etching - CF₄ and CHF₃ chemistry with Ar and O₂

^b Silicon and metal metal etching - SF₆ chemistry with Ar and O₂

**High step coverage - Fully conformal deposition (Ti, Al & Au only)

¹POA for 4" wafers (Ag & In only)

²POA for 4" wafers (In & Ag excluded)

POA: price on application

Au = £4/nm

Ti = £1/nm

Pd = £2/nm

Al = £0.5/nm

In = £1/nm